

Patent Docket No. 249/163 24736-7002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:) Group Art Unit: 3742
David Freundlich, et al.) Examiner: Fadi Dahbour
Serial No.: 09/724,670))
Filed: November 28, 2000	RECEIVED
For: APPARATUS FOR CONTROLLING THERMAL DOSING IN A THERMAL TREATMENT SYSTEM (As Amended Herein) AMENDMENT AND RESPONSE TO RESTR	RECEIVED OCT 2 5 2002 TECHNOLOGY CENTER R3700 ICTION REQUIREMENT TRANSMITTAL
Box: Non-Fee Commissioner for Patents Washington, D.C. 20231	
Sir:	
Transmitted herewith is an Amendment and pages) for the above-identified application.	Response to Restriction/Election Requirement (3 Respectfully submitted, BIGHAM McCUTCHEN LLP
Dated: 10(8/02	By: David T. Burse Reg. No. 37,104
BINGHAM McCUTCHEN LLP Three Embarcadero Center San Francisco, CA 94111-4067 (650) 849-4400	Rog. 140. 57,104
CERTIFICATE (
(37 C.F.R. §1.8a)	

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as First Class Mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

October 9, 2002

Date of Deposit 52091153.1/24736-7002

Maritza Kidd

Name of Person Mailing Pape

Signature of Person Mailing Paper